

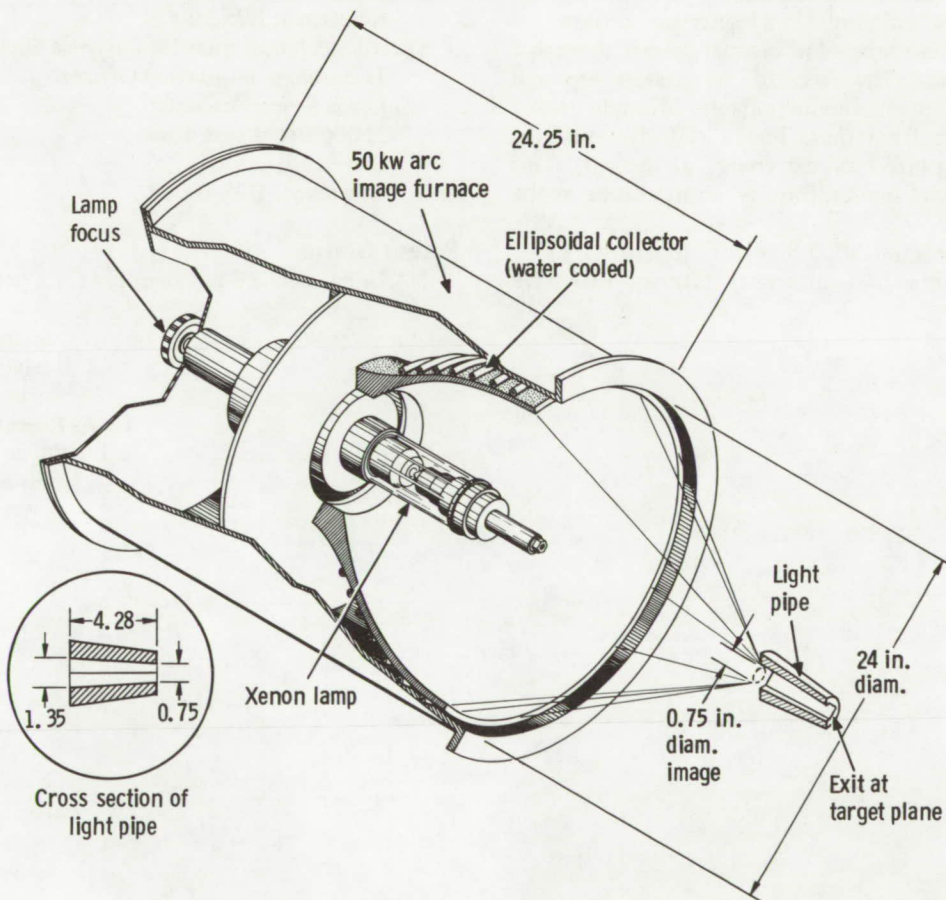
# NASA TECH BRIEF

## Lewis Research Center



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### Uniform High Irradiance Source



**The Problem:**

To provide uniform irradiance levels up to  $2.5 \times 10^7$  watts/m<sup>2</sup> (15 BTU/in<sup>2</sup>-sec) on a 1.91 cm (0.75 in) diameter target with a non-uniformity ratio of less than 1.10. The non-uniformity ratio is defined as the ratio of maximum to minimum irradiance level within the target diameter. At the time of this development, compact short arc lamps in the 20-30 Kw range were all that was available for design of an arc image furnace. Designs utilizing lens imagery suffer reduced efficiency due to the number of reflective and refractive elements required.

**The Solution:**

A new 50 Kw xenon short arc lamp mounted within an elliptical collector provides irradiance levels up to  $4.4 \times 10^7$  watts/m<sup>2</sup> (26.6 BTU/in<sup>2</sup>-sec) with a non-uniformity ratio of 3.30. An energy mixer or light pipe between the lamp source and the target (see figure) improves the non-uniformity to the required ratio.

(continued overleaf)

### How It's Done:

The uniform high level irradiance has been achieved by utilizing an arc image furnace and straight taper light pipe. The arc image furnace is composed of a 50 Kw jet-pinch xenon short arc lamp mounted within an elliptical collector. The lamp is unique in three ways. First, it does not require a high voltage discharge across the lamp and current surge to start the lamp. Instead the cathode extends to almost touching the anode, and through a ballast resistor in series, strikes an arc and retracts maintaining a small arc. After retracting, the ballast resistor is dropped out of the circuit and the lamp operates directly from the power supply. Second, the anode surface is concave to allow for increased water cooling surface area on the backside and arc stability. The third unique feature is the constraint of the plasma at the cathode by the higher pressure discharge of xenon gas around the cathode towards the anode. This restricts the shape of the plume and results in a higher arc radiance.

The light pipe is a tapered hexagonal passage through a water cooled block. The faces of the passage are high quality first surface aluminum mirrors. Multiple reflections of the rays from these highly reflective surfaces produce a mixing effect of the energy at the exit. This results in a minimal non-uniformity of irradiance at the target plane.

Irradiance levels up to  $2.8 \times 10^7$  watts/m<sup>2</sup> (17.3 BTU/in<sup>2</sup>-sec) with a non-uniformity ratio of 1.07 have been measured.

### Notes:—

1. The facility can be used in the study of the structural integrity of materials subjected to extreme heating rates in the development of turbine blades, rocket nozzles, and reactors.
2. Further information is available in the following reports:

NASA SP-298 (N72-22250), Development of a High Irradiance Source

NASA CR-134523 (N74-16613), Fundamental Study of Transpiration Cooling

Copies may be obtained at cost from:  
Aerospace Research Applications Center  
Indiana University  
400 East Seventh Street  
Bloomington, Indiana 47401  
Telephone: 812-337-7833  
Reference: B75-10008

3. Specific technical questions may be directed to:  
Technology Utilization Officer  
Lewis Research Center  
21000 Brookpark Road  
Cleveland, Ohio 44135  
Reference: B75-10008

### Patent Status:

NASA has decided not to apply for a patent.

Source: A.R. Lunde  
Boeing Aerospace Co.  
under contract to  
Lewis Research Center, and  
A. Fortini and D.R. Buchele  
Lewis Research Center  
(LEW-12360)